



LTW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4044**
Akihisa HONGO et al. : Attorney Docket No. 2003_1822A
Serial No. 10/735,771 : Group Art Unit 1763
Filed December 16, 2003 : Examiner Sylvia Macarthur
SUBSTRATE PROCESSING APPARATUS : Mail Stop AF
AND SUBSTRATE PROCESSING METHOD

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Responsive to the Final Office Action mailed August 9, 2006, please amend the above-identified application as follows: